

**Application Data Sheet****Application Information**

Application Type::	Divisional
Subject Matter::	Utility
CD-ROM or CD-R:	None
Title::	METHOD FOR PRODUCING SOI WAFER AND SOI WAFER
Attorney Docket Number::	109725.01
Total Drawing Sheets::	4
Small Entity::	No

**Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Hiroji
Family Name::	AGA
City of Residence::	Gunma
Country of Residence::	Japan

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Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Naoto
Family Name::	TATE
City of Residence::	Gunma
Country of Residence::	Japan

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Applicant Authority type:: Inventor  
 Primary Citizenship Country:: Japan  
 Status:: Full Capacity  
 Given Name:: Susumu  
 Family Name:: KAWABARA  
 City of Residence:: Gunma  
 Country of Residence:: Japan

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Applicant Authority type:: Inventor  
 Primary Citizenship Country:: Japan  
 Status:: Full Capacity  
 Given Name:: Kiyoshi  
 Family Name:: MITANI  
 City of Residence:: Gunma  
 Country of Residence:: Japan

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### Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	Division of	09/857,803	06/11/2001
Which is a	National Stage of	PCT/JP00/07111	10/13/2000
Assignee Information			
Assignee Name::		Shin-Etsu Handotai Co., Ltd.	
Street of mailing address::		4-2 Marunouchi 1-chome, Chiyoda-ku	
City of mailing address::		Tokyo	
Country of mailing address::		Japan	